



JPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79569

Yoshihiko UCHIDA, et al.

Appln. No.: 10/765,220

Group Art Unit: 2818

Confirmation No.: 7643

Examiner: Andy Huynh

Filed: January 28, 2004

For: ORGANIC SEMICONDUCTOR ELEMENT HAVING HIGH INSULATION
STRENGTH AND FABRICATION METHOD THEREOF (as amended)

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Office Action of June 14, 2005, please amend the above-identified application as follows.

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